

**RECEIVED
CENTRAL FAX CENTER****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

MAR 05 2004

In re Application of:

Inventors: Apostolos T. Voutsas, Yukuhiki Nakata
and Takeshi Hosoda

Serial No: 09/696,813

Filed: September 5, 2002

Title: A SEMICONDUCTOR DEVICE AND
METHOD OF CREATING THE SAME
UTILIZING METAL INDUCED
CRYSTALLIZATION WHILE
SUPPRESSING PARTIAL SOLID
PHASE CRYSTALLIZATION**PATENT
APPLICATION**Attorney Docket No.
SLA0674468

Group No. 2823

Examiner: Khiem D.
Nguyen**OFFICIAL***File Only***CERTIFICATE OF TRANSMITTAL UNDER 37 C.F.R. § 1.8**I hereby certify that this correspondence is being facsimile transmitted to the
United States Patent and Trademark Office at Fax No. (703) 872-9306 on
March 5, 2004David C. Ripma, Reg. No. 27,672
Signature Date: March 5, 2004Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**SUPPLEMENTAL INFORMATION DISCLOSURE
STATEMENT UNDER 37 C.F.R. §1.97(d)**

Sir:

Applicants herewith submit information in the above-identified application for
consideration by the Examiner. A final Office Action having been issued and the issue fee
not having been paid, this Information Disclosure Statement is submitted under 37 C.F.R.
§1.97(d).

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